

2823

TRANSMITTAL LETTER			Case No. 10519-29
Serial No. 09/918,853	Filing Date July 30, 2001	Examiner F. Toledo	Group Art Unit 2823
Inventor(s) VYVODA ET AL.			
Title of Invention PROCESS FOR FABRICATING A DIELECTRIC FILM USING PLASMA OXIDATION			

TO THE COMMISSIONER FOR PATENTS

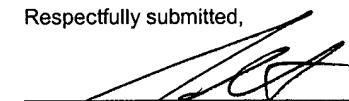
Transmitted herewith is Transmittal Letter (in duplicate); Response to Restriction Requirement; and Return Postcard.

- Small entity status of this application under 37 CFR § 1.27 has been established by verified statement previously submitted.
- A verified statement to establish small entity status under 37 CFR §§ 1.9 and 1.27 is enclosed.
- Petition for a month extension of time.
- No additional fee is required.
- The fee has been calculated as shown below:

		Small Entity		Other Than Small Entity	
		Rate	Add'l Fee	Rate	Add'l Fee
Total	Claims Remaining After Amendment	x \$9=		x \$18=	0
Indep.	Minus	x 42=	0	x \$84=	0
First Presentation of Multiple Dep. Claim		+\$140=	0	+\$280=	0
		Total add'l fee	\$0	Total add'l fee	\$0

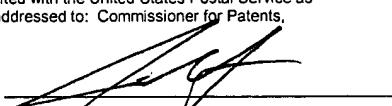
- Please charge Deposit Account No. 23-1925 (BRINKS HOFER GILSON & LIONE) in the amount of \$ _____. A duplicate copy of this sheet is enclosed.
- A check in the amount of \$ to cover the filing fee is enclosed.
- The Commissioner is hereby authorized to charge payment of any additional filing fees required under 37 CFR § 1.16 and any patent application processing fees under 37 CFR § 1.17 associated with this communication or credit any overpayment to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.
- I hereby petition under 37 CFR § 1.136(a) for any extension of time required to ensure that this paper is timely filed. Please charge any associated fees which have not otherwise been paid to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.

Respectfully submitted,


 Joseph F. Hetz
 Registration No. 41,070
 Attorney for Applicant
 Customer No.

BRINKS HOFER GILSON & LIONE
 P.O. BOX 10395
 CHICAGO, ILLINOIS 60610
 (312) 321-4200

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on January 30, 2003.

Date: 1/30/03 Signature: 

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hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on January 30, 2003

Date of Deposit

Joseph F. Hetz - Reg. No. 41,070

Name of Applicant, Assignee or
Registered Representative

Signature

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Our Case No. 10519/29

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Vyyoda et al.)
Serial No.: 09/918,853)
Filed: July 30, 2001)
For: Process for Fabricating a Dielectric)
Film Using Plasma Oxidation)

Examiner: F. Toledo
Group Art Unit: 2823

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the restriction requirement mailed December 31, 2002, Applicants elect
Group I (Claims 1-24, 31-40, and 55-71) without traverse.

Dated: January 30, 2003

Respectfully submitted,

BRINKS HOFER GILSON & LIONE
P.O. Box 10395
Chicago, Illinois 60610
(312) 321-4719

Joseph F. Hetz
Reg. No. 41,070
Attorney for Applicants

#8/Election
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